



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Ichio YUDASAKA et al.

Group Art Unit: 2826

Application No.: 09/936,040

Examiner: A. Sefer

Filed: December 11, 2001

Docket No.: 110554

For: A THIN FILM TRANSISTOR AND A METHOD FOR MANUFACTURING  
THEREOF

q/Election  
7-302  
A. Sefer

**RESPONSE TO RESTRICTION REQUIREMENT**

Director of the U.S. Patent and Trademark Office  
Washington, D.C. 20231

Sir:

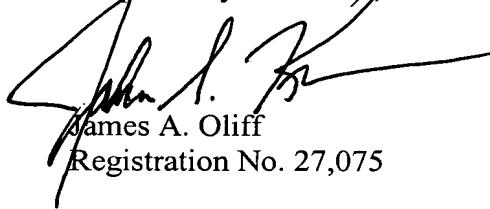
In reply to the Restriction Requirement mailed May 30, 2002, Applicants  
provisionally elect Group I, claims 1-7, 13-16 and 17 drawn to Device, with traverse.

It is also respectfully submitted that the subject matter of all claims 1-18 is  
sufficiently related that a thorough search for the subject matter of any one Group of claims  
would encompass a search for the subject matter of the remaining claims. Thus, it is  
respectfully submitted that the search and examination of the entire application could be  
made without serious burden. See MPEP §803 in which it is stated that "if the search and  
examination of the entire application can be made without serious burden, the Examiner must  
examine it on the merits even though it includes claims to distinct or independent inventions"  
(emphasis added). It is respectfully submitted that this policy should apply in the present  
application in order to avoid unnecessary delay and expense to Applicants and duplicative  
examination by the Patent Office.

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Thus, withdrawal of the Restriction Requirement is respectfully requested.

Respectfully submitted,



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JAO:JSK/kap

Date: June 26, 2002

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